

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

FAX RECEIVED

Inventors:	Blaine R. Spady; John D. Heaton	MAR 30 2006
Assignee:	Nanometrics Incorporated	OFFICE OF PETITIONS
Title:	Metrology/Inspection Positioning System	
Serial No.:	09/458,123	Filing Date: December 8, 1999
Examiner:	Gordon Stock	Group Art Unit: 2877
Docket No.:	NAN035 US	Confirmation No.: 8470

Santa Clara, California
March 30, 2006

Mail Stop Petition
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

This Amendment is filed with a Request for Continued Examination and a Petition to Withdraw from Issuance under 37 C.F.R. §1.313(c). Please enter the following amendment before taking action on the merits of the above-referenced application.

SILICON VALLEY

PATENT GROUP LLP

2350 Mission College Blvd.
Suite 360
Santa Clara, CA 95054
(408) 982-8200
FAX (408) 982-8210